

Refine Search

10/675 049

Search Results -

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| L8 and measuring | 2 |

Database:

US Pre-Grant Publication Full-Text Database
 US Patents Full-Text Database
 US OCR Full-Text Database
 EPO Abstracts Database
 JPO Abstracts Database
 Derwent World Patents Index
 IBM Technical Disclosure Bulletins

Search:

L11

Refine Search

Recall Text



Clear

Interrupt

Search History

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side by side

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result set

DB=USPT; PLUR=YES; OP=ADJ

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| <u>L11</u> | L8 and measuring | 2 | <u>L11</u> |
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| <u>L9</u> | L8 and discharge | 6 | <u>L9</u> |
| <u>L8</u> | L7 and feed | 16 | <u>L8</u> |
| <u>L7</u> | L2 and (gas near2 flow) | 52 | <u>L7</u> |
| <u>L6</u> | L5 and discharge | 8 | <u>L6</u> |
| <u>L5</u> | L2 and (feed) | 41 | <u>L5</u> |
| <u>L4</u> | L2 and (feed near6 discharge) | 0 | <u>L4</u> |
| <u>L3</u> | L2 and (feed near discharge) | 0 | <u>L3</u> |
| <u>L2</u> | furnace near5 (vapor adj phase) | 174 | <u>L2</u> |
| <u>L1</u> | furnance near5 (vapor adj phase) | 0 | <u>L1</u> |

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Search Results - Record(s) 1 through 2 of 2 returned.

☐ 1. Document ID: US 6742701 B2

L11: Entry 1 of 2

File: USPT

Jun 1, 2004

US-PAT-NO: 6742701

DOCUMENT-IDENTIFIER: US 6742701 B2

TITLE: Bump forming method, presoldering treatment method, soldering method, bump forming apparatus, presoldering treatment device and soldering apparatus

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw D |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|--------|
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|--------|

☐ 2. Document ID: US 6184049 B1

L11: Entry 2 of 2

File: USPT

Feb 6, 2001

US-PAT-NO: 6184049

DOCUMENT-IDENTIFIER: US 6184049 B1

TITLE: Method for fabricating compound semiconductor epitaxial wafer and vapor phase growth apparatus using the same

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw D |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|--------|
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| Terms | Documents |
| L8 and measuring | 2 |

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Search Results - Record(s) 1 through 5 of 5 returned.

☐ 1. Document ID: US 6566199 B2

L10: Entry 1 of 5

File: USPT

May 20, 2003

US-PAT-NO: 6566199

DOCUMENT-IDENTIFIER: US 6566199 B2

TITLE: Method and system for forming film, semiconductor device and fabrication method thereof

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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☐ 2. Document ID: US 6074202 A

L10: Entry 2 of 5

File: USPT

Jun 13, 2000

US-PAT-NO: 6074202

DOCUMENT-IDENTIFIER: US 6074202 A

TITLE: Apparatus for manufacturing a semiconductor material

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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☐ 3. Document ID: US 4982693 A

L10: Entry 3 of 5

File: USPT

Jan 8, 1991

US-PAT-NO: 4982693

DOCUMENT-IDENTIFIER: US 4982693 A

TITLE: Semiconductor vapor phase growing apparatus

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|

☐ 4. Document ID: US RE33326 E

L10: Entry 4 of 5

File: USPT

Sep 11, 1990

US-PAT-NO: RE33326

DOCUMENT-IDENTIFIER: US RE33326 E

TITLE: Semiconductor vapor phase growing apparatus

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWC | Draw D |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|-----|--------|
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☐ 5. Document ID: US 4430959 A

L10: Entry 5 of 5

File: USPT

Feb 14, 1984

US-PAT-NO: 4430959

DOCUMENT-IDENTIFIER: US 4430959 A

TITLE: Semiconductor vapor phase growing apparatus

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWC | Draw D |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|-----|--------|
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Search Results - Record(s) 1 through 6 of 6 returned.

☐ 1. Document ID: US 6742701 B2

L9: Entry 1 of 6

File: USPT

Jun 1, 2004

US-PAT-NO: 6742701

DOCUMENT-IDENTIFIER: US 6742701 B2

TITLE: Bump forming method, presoldering treatment method, soldering method, bump forming apparatus, presoldering treatment device and soldering apparatus

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw. De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|----------|
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|----------|

☐ 2. Document ID: US 6482762 B1

L9: Entry 2 of 6

File: USPT

Nov 19, 2002

US-PAT-NO: 6482762

DOCUMENT-IDENTIFIER: US 6482762 B1

TITLE: NOx conversion catalyst rejuvenation process

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw. De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|----------|
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☐ 3. Document ID: US 6379416 B1

L9: Entry 3 of 6

File: USPT

Apr 30, 2002

US-PAT-NO: 6379416

DOCUMENT-IDENTIFIER: US 6379416 B1

TITLE: Method and device for melt-treating incineration residue containing salts

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw. De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|----------|
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|----------|

☐ 4. Document ID: US 6184049 B1

L9: Entry 4 of 6

File: USPT

Feb 6, 2001

US-PAT-NO: 6184049

DOCUMENT-IDENTIFIER: US 6184049 B1

TITLE: Method for fabricating compound semiconductor epitaxial wafer and vapor phase growth apparatus using the same

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw Ds |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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☐ 5. Document ID: US 5308810 A

L9: Entry 5 of 6

File: USPT

May 3, 1994

US-PAT-NO: 5308810

DOCUMENT-IDENTIFIER: US 5308810 A

TITLE: Method for treating contaminated catalyst

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw Ds |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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☐ 6. Document ID: US 5294242 A

L9: Entry 6 of 6

File: USPT

Mar 15, 1994

US-PAT-NO: 5294242

DOCUMENT-IDENTIFIER: US 5294242 A

TITLE: Method for making metal powders

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw Ds |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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Search Results - Record(s) 1 through 8 of 8 returned.

☐ 1. Document ID: US 6742701 B2

L6: Entry 1 of 8

File: USPT

Jun 1, 2004

US-PAT-NO: 6742701

DOCUMENT-IDENTIFIER: US 6742701 B2

TITLE: Bump forming method, presoldering treatment method, soldering method, bump forming apparatus, presoldering treatment device and soldering apparatus

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|-----|---------|
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☐ 2. Document ID: US 6482762 B1

L6: Entry 2 of 8

File: USPT

Nov 19, 2002

US-PAT-NO: 6482762

DOCUMENT-IDENTIFIER: US 6482762 B1

TITLE: NOx conversion catalyst rejuvenation process

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|-----|---------|
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|-----|---------|

☐ 3. Document ID: US 6379416 B1

L6: Entry 3 of 8

File: USPT

Apr 30, 2002

US-PAT-NO: 6379416

DOCUMENT-IDENTIFIER: US 6379416 B1

TITLE: Method and device for melt-treating incineration residue containing salts

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|-----|---------|
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|-----|---------|

☐ 4. Document ID: US 6184049 B1

L6: Entry 4 of 8

File: USPT

Feb 6, 2001

US-PAT-NO: 6184049

DOCUMENT-IDENTIFIER: US 6184049 B1

TITLE: Method for fabricating compound semiconductor epitaxial wafer and vapor phase growth apparatus using the same

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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☐ 5. Document ID: US 5925165 A

L6: Entry 5 of 8

File: USPT

Jul 20, 1999

US-PAT-NO: 5925165

DOCUMENT-IDENTIFIER: US 5925165 A

TITLE: Process and apparatus for the 3-stage treatment of solid residues from refuse incineration plants

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|

☐ 6. Document ID: US 5308810 A

L6: Entry 6 of 8

File: USPT

May 3, 1994

US-PAT-NO: 5308810

DOCUMENT-IDENTIFIER: US 5308810 A

TITLE: Method for treating contaminated catalyst

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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☐ 7. Document ID: US 5294242 A

L6: Entry 7 of 8

File: USPT

Mar 15, 1994

US-PAT-NO: 5294242

DOCUMENT-IDENTIFIER: US 5294242 A

TITLE: Method for making metal powders

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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☐ 8. Document ID: US 3608609 A

L6: Entry 8 of 8

File: USPT

Sep 28, 1971

US-PAT-NO: 3608609

DOCUMENT-IDENTIFIER: US 3608609 A

TITLE: HEAT-EXCHANGING METHOD AND APPARATUS

| Full | Title | Citation | Front | Review | Classification | Date | Reference | | | Claims | KWIC | Draw De |
|------|-------|----------|-------|--------|----------------|------|-----------|--|--|--------|------|---------|
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